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APPLICANTS	ri Talue IADAN		-					
	ri, Tokyo, JAPAN;							
	ATA ******************	* none						
JAPAN 2002	ICATIONS ************************************	·	ED					
** 12/10/2003								
Foreign Priority claimed 35 USC 119 (a-d) conditions yes no Met after met Verified and Acknowledged Examiner's Signature Initials			STATE OR COUNTRY JAPAN	SHEETS DRAWING 4		TOTAL CLAIMS 19		INDEPENDENT CLAIMS 2
ADDRESS 23995								
TITLE			-					
Semiconductor device fabrication method using oxygen ion implantation								
	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:				All Fees			
					1.16 Fees (Filing)			
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